

## N RATEMANTITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Isamu HAYASHI et al.

Appln. No.: 09/897,902

Group Art Unit: 2112

Filed: July 5, 2001

Examiner: C. Lee

For: MICROPROCESSOR, SEMICONDUCTOR MODULE AND DATA

PROCESSING SYSTEM

## AMENDMENT ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION (RCE)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to the commencement of continued examination, please amend the above-identified patent application as indicated below.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.